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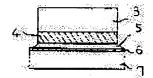
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(54) CONDUCTOR MATERIAL

(57)Abstract:

PURPOSE: To relax thermal stresses in joining ceramic to metal by making a composite body with glass or glass ceramic containing essential constituents of oxide of copper, Al2O3 and SiO2 and with a conductor.

CONSTITUTION: A mixture of 15W40% of glass powder of mean particle diameter of $1\mu m$ selected to constitute a total amount of 100% with 55W65% of SiO2, 10W20% of Al2O3 and 15W25% of Cu2O as a fundamental composition and of 85W60% of Cu powder of mean particle diameter of $0.5\mu m$ is sintered in N2 at $700W1000^\circ$ C to make a plate. When joining Cu to Al2O3 or SiC, the plate is used as a thermal stress relaxation member in a structure sandwiching the plate between the metal and ceramic. Since the plate of sintered body can be made to have a coefficient of thermal expansion of $35W120\times10^{-7}/^\circ$ C, the plate is useful as a thermal stress relaxation member between electronic components and structural materials to improve the reliability of the electronic components and structural materials.



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